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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/881,218	06/13/2001	Ansheng Liu	042390P11429	7592

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James Y. Go  
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP  
Seventh Floor  
12400 Wilshire Boulevard  
Los Angeles, CA 90025-1026

EXAMINER

PRITCHETT, JOSHUA L

ART UNIT

PAPER NUMBER

2872

DATE MAILED: 05/27/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

# Office Action Summary

Application No.

09/881,218

Applicant(s)

LIU ET AL.

Examiner

Joshua L. Pritchett

Art Unit

2872

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

## Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

## Status

- 1) ☒ Responsive to communication(s) filed on 12 July 2004.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

## Disposition of Claims

- 4) ☒ Claim(s) 1,2,4,7 and 30-43 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☒ Claim(s) 1,2,4,7 and 30-39 is/are allowed.
- 6) ☒ Claim(s) 40-43 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

## Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 02 April 2003 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

## Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some \* c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
  - ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

## Attachment(s)

- ☒ Notice of References Cited (PTO-892)
- ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- ☒ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  
Paper No(s)/Mail Date 1/05, 11/04, 7/04.
- ☐ Interview Summary (PTO-413)  
Paper No(s)/Mail Date. \_\_\_\_\_.
- ☐ Notice of Informal Patent Application (PTO-152)
- ☐ Other: \_\_\_\_\_.

### **DETAILED ACTION**

This action is in response to Request for Continued Examination and Amendment filed July 12, 2004. Claims 37-43 have been added as requested by the applicant.

#### ***Claim Rejections - 35 USC § 102***

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 40-43 are rejected under 35 U.S.C. 102(b) as being anticipated by Chwalck (US 5,418,802).

Regarding claim 40, Chwalck discloses directing an optical beam into a first end of an optical path (4) having the first and second end disposed in a semiconductor substrate (5; Fig. 4B); establishing a Bragg grating (7) within the optical path with a plurality of electrodes (8 and 9) positioned to perturb an effective index of refraction a plurality of times along the optical path (Fig. 4C); reflecting a first portion of the optical beam having a first center wavelength back out from the first end of the optical path with the Bragg grating and tuning the Bragg grating to reflect a second portion of the optical beam having a second center wavelength back out from the first end of the optical path (col. 7 lines 31-65; col. 8 line 67 – col. 9 line 19).

Regarding claim 41, Chwalck discloses applying a voltage to the plurality of electrodes to perturb a concentration of free charge carriers a plurality of times along the optical path (col. 7 lines 31-65; col. 8 line 67- col. 9 line 19).

Regarding claim 42, Chwalck discloses modulating charge in the optical path by modulating a voltage applied to the plurality of electrodes (col. 7 lines 31-65; col. 8 line 67- col. 9 line 19).

Regarding claim 43, Chwalck discloses confining the optical beam to remain within the optical path between the first and second ends with an optical waveguide disposed in the semiconductor substrate between the first and second ends (col. 6 lines 47-52).

### *Response to Arguments*

Applicant's arguments with respect to claim 40 have been considered but are moot in view of the new ground(s) of rejection. The applicant argued that the Weber reference failed to teach or suggest all the claim limitations, specifically the Bragg grating. The examiner has rejected the newly added claim under Chwalck.

### *Allowable Subject Matter*

Claims 1, 2, 4, 7, 30-39 are allowed.

The following is an examiner's statement of reasons for allowance:

Regarding claims 1 and 37, the prior art of record fails to teach or suggest directing an optical beam into an optical path and reflecting a first portion of the beam having a first wavelength back out of the optical path, with first and second pluralities of silicon and polysilicon interfaces oriented substantially perpendicular to the semiconductor substrate. Samara-Rubio (US 6,600,864) teaches a tunable grating with polysilicon (135 and 137) extending into the optical path (103) and oriented substantially perpendicular to the semiconductor substrate (102). Samara-Rubio lacks the claimed silicon and polysilicon interfaces. Samara-Rubio teaches the use of two polysilicon capacitors but the polysilicon only interfaces with the insulators (153 and 155) therefore no interface between the silicon of the optical path and the polysilicon of the capacitors exists.

Regarding claim 30, the prior art of record fails to teach or suggest the use of a plurality of insulated conductor structures protruding into the optical path disposed in a semiconductor substrate and reflecting a first portion of the optical beam back out the first end of the optical path.

The remaining claims depend from claims 1, 30 and 37 and are allowable for the same reasons.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

*Conclusion*


The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Samara-Rubio (US 6,628,450) teaches an insulated charge modulator disposed in the optical beam path (Fig. 1). However, Samara-Rubio (US 6,628,450) fails to qualify as prior art because it was filed and published subsequent to the filing of the current application.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joshua L. Pritchett whose telephone number is 571-272-2318. The examiner can normally be reached on Monday - Friday 7:00 - 3:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Drew A. Dunn can be reached on 571-272-2312. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

JLP 

  
**DREW A. DUNN**  
**SUPERVISORY PATENT EXAMINER**